

Notice of References Cited

Application/Control No.

10/565,517

Applicant(s)/Patent Under
Reexamination
KUMAZAWA, ITSUO

Examiner

LILIANA CERULLO

Art Unit

4163

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,313,230	05-1994	Venolia et al.	345/163
	B	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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